



Attorney Docket No. 0553-0242.01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Fee only

In Re Application of:

Shunpei YAMAZAKI et al

Serial No.: 10/790,972

Filed: March 2, 2004

Art Unit: 2824

For: THIN FILM FORMING DEVICE, METHOD
OF FORMING A THIN FILM, AND SELF-
LIGHT-EMITTING DEVICE

) I hereby certify that this correspondence
) is being deposited with the United States
) Postal Service as first class mail in an
) envelope addressed to:
) Commissioner for Patents, P.O. Box 1450,
) Alexandria, VA 22313-1450, on June 30,
) 2005

Cristian M. Vaz

Date: June 30, 2005

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Pursuant to 37 C.F.R. §1.97, as revised on February 4, 1992,

07/14/2005 1135 OG 23-24, Applicant hereby calls the Examiner's attention to
LAWRENC 00000002 501039 10/790972
01 FC:1806 documents SA listed on the attached form, which documents may be
material to the examination of this application. Copies of the
references are enclosed herewith for the Examiner's consideration.

The family of JP Patent no. 2000-113979 cited herein includes:
US Patent No. 6,514,649 B1
US Patent No. 6,794,816 B2
US Patent Application Publication no. US 2003/0132703 A1

No inference should be drawn that the attached list sets forth
a comprehensive investigation of the prior art, that any or all are
pertinent to the invention, or that any apparatus disclosed is
equivalent to the subject invention.